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PATENT
SD6957S97604

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Clews et al

Group No.: 1765

Serial No.: 10 / 010,850

Examiner: Tran, B.

Filed: December 5, 2001

Paper No.: 14

For: Selective Etchant for Oxide Sacrificial Material in Semiconductor Device Fabrication

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants have carefully reviewed the Office Action of July 23, 2004 and submit the following in complete response thereto. Reconsideration of the claims and the amendments presented herein is respectfully requested in order to place the application in condition for allowance.

